



Docket No.: 65781-012

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Yoshihiko NEMOTO, et al.

Serial No.: 10/603,982

Filed: June 26, 2003

: Customer Number: 20277

: Confirmation Number: 3854

: Group Art Unit: 2812

: Allowed: December 11, 2003

: Examiner: Gurley

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For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE WITH RECESSES USING ANODIC OXIDE (As Amended)

LETTER SUBMITTING FORMAL DRAWINGS

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Notice of Allowability dated December 11, 2003, submitted herewith are two (2) sheets of Formal Drawings in connection with the above referenced application.

Respectfully submitted,

MCDERMOTT, WILL & EMERY


Stephen A. Becker
Registration No. 26,527

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 SAB:BD
Facsimile: (202) 756-8087
Date: March 10, 2004